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(PTO ASSISTANCE)

Application : <u>10 676 628</u>	Examiner : <u>F Font</u>	GAU : <u>2883</u>
From: <u>mg</u>	Location: <u>IDC</u> FMF FDC	Date: <u>12.19.05</u>
Tracking #: <u>10 676 628</u>		Week Date: <u>07.18.05</u>

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<input checked="" type="checkbox"/> 1449	<u>10.13.04</u>	<input type="checkbox"/> Continuing Data
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[RUSH] MESSAGE: _____

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Other Reference, on 'line A28', is illegible.

[XRUSH] RESPONSE: _____

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REV 10/04

LIST OF PATENTS AND OTHER ITEMS FOR APPLICANT'S
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(Use several sheets if necessary)

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263/176

NO.

SERIAL NO.
09/837,829APPLICANT:
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April 17, 2001GROUP:
2633

Moise

SB		Jorg, Guttman; Joachim; Huber, Hans-Peter; "Optical Backplanes With Integrated Polymer Waveguides," <i>Journal of Optical Engineering</i> , Vol. 39, No. 3, March 2000	
A29	SB	Mueller, Raluca; Pavelescu; and Manea, Elena; "3D Microstructures Integrated With Optical Waveguides and Photodiodes on Silicon," <i>MELECOB 1998 9th Mediterranean Electromechanical Conference Proceedings</i> , Vol. 1, May 18-20, 1998	
A30	SB	Namba, Tohru; Uehara, Akihito; et al.; "High-Efficiency Micromirrors and Branched Optical Waveguides on Si Chips," <i>Japanese Journal of Applied Physics, Part 1</i> , Vol. 35, No. 2B, August 21-24, 1995	
A31	SB	Oillier, Eric; Chabrol, Claude; et al.; "1 x 8 Micro-Mechanical Switches Based on Moving Waveguides for Optical Fiber Network Switching," <i>2000 IEEE/LEOS International Conference on Optical MEMS</i> , August 21-24, 2000	
A32	SB	Oillier, Eric; and Mottier, P.; "Micro-Opto-Electro-Mechanical Systems: Recent Developments and LEIT's Activities," <i>Proceedings of the SPIE - The International Society for Optical Engineering</i> , Vol. 4076, May 22-24, 2000	
A33	SB	Shubin, I.; and Wa, P.L.K.; "Electrostatically Actuated 1 x 2 Micro-Mechanical Optic Switch," <i>Electronics Letters</i> , Vol. 37, No. 7; March 29, 2001	
A34	SB	Storgaard-Larsen, Torben; "Plasma-Enhanced Chemical Vapor Deposited Silicon Oxynitride Films for Optical Waveguide Bridges for Use in Mechanical Sensors," <i>Journal of the Electromechanical Society</i> , Vol. 144, No. 4, April 1997	
A35	SB	Voges, E.; Hoffmann, M.; "FB1 Optical Waveguides on Silicon Combined With Micromechanical Structures," <i>Advanced Applications of Lasers in Materials and Processing; LEOS Summer Optical Meeting, 1996; IEEE, Piscataway, New Jersey, 96TH8154</i>	
A36	SB	Yokoyama, S.; Nagata, T.; and Kuroda, Y.; et al.; "Optical Waveguides on Silicon Chips," <i>Journal of Vacuum Science & Technology A</i> , Vol. 13, No. 3, May-June 1995	

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant